

AMENDMENT TRANSMITTAL LETTER (Large Entity)				D	Docket No.	
Applicant(s): Masashi Maekawa and Yukihiko Nakata				SLA0648		
Serial No Filing		Date	Examiner	Group Art Unit		
		8, 2002	Jennifer M. Dolan	2813		
					CEIVED	
Invention: Apparatus and Method for Low-Temperature Oxidation of Silicon CENTRAL FAX CENTER						
NOV					1 0 2003	
TO THE COMMISSIONER FOR PATENTS:						
Transmitted herewith is an amendment in the above identified application.						
The fee has been calculated and is transmitted as shown below. CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	11 -	44 =	0	x \$18.00	\$00.00	
INDEP. CLAIMS	2 -	3 =	0	x \$86.00	\$0.00	
Multiple Dependent Claims (check if applicable) \$0.00						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$00.00						
The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457. A duplicate copy of this sheet is enclosed. X Any additional fees required under 37 C.F.R. 1.16. X Affly patent application processing fees under 37 C.F.R. 1.17. Dated: NOVEMBER 10, 2003 I hereby certify that this correspondence is being facsimile transmitted to the United States Fatent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9318 on November 10, 2003.						
Note: Each paper must be include: X This Amen X Response to Attachmer	ive its own certificate or transdument Transmittal Le under 37 CFR § 1.111	etter (Duplicate Att	ached)	nitted paper Th	page(s) page(s) page(s) page(s) page	
Total pages, including this Transmittal: 9						